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EXPRESS MAIL LABEL NO. EV314046062US

DATED: 16 JULY 2003

ATTY DOCKET: MXIC 1532-1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

MS Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

UTILITY PATENT APPLICATION TRANSMITTAL LETTER

Enclosed for filing is an original patent application by Chih Yuan HUANG and Jonason CHEN for **METHOD FOR FORMING SILICON FILM WITH CHANGING GRAIN SIZE BY THERMAL PROCESS.**

Also enclosed are:

- [x] 6 sheet(s) of formal drawing(s);
- [x] 11 sheet(s) of specification/abstract;
- [x] 2 sheet(s) of claims;
- [x] Application Data Sheet;
- [x] an Assignment document and form PTO-1595;
- [x] combined declaration and power of attorney.
- [x] Disclosure Statement, PTO-Form SB/08 and 19 references.

The fee has been calculated as follows:

CLAIMS					
	NO. OF CLAIMS		EXTRA CLAIMS	RATE	FEE
<b>Basic Application Fee</b>					<b>\$750.00</b>
Total Claims	11	MINUS 20 =	0	X \$18.00 =	
Independent Claims	6	MINUS 3 =	3	X \$84.00 =	\$252.00
If multiple dependent claims are presented, add \$280.00					
<b>Total Application Fee</b>					<b>\$1002.00</b>
If small entity status is claimed, subtract 50% of Total Application Fee					
Add Recording Fee of \$40.00 if Assignment document is enclosed					\$40.00
<b>TOTAL APPLICATION FEE DUE</b>					<b>\$1042.00</b>

- [x] Check No. 2397 in the amount of \$1042 is enclosed.
- [x] The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Deposit Account No. 50-0869 (MXIC 1532-1). A copy of this transmittal is enclosed.

Respectfully submitted,

Date: 16 July 2003

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